



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/763,578 Confirmation No.: 4912
Applicant : BOWER, ROBERT W.
Title : STRUCTURES, MATERIALS AND METHODS FOR
FABRICATION OF NANOSTRUCTURES BY TRANSPOSED
SPLIT OF ION CUT MATERIALS
Filed : 01/21/2004
TC/A.U. : 2823
Examiner : JEFFERSON, QUOVAUNDA
Docket No. : BOW5075.14A1
Cust. No. : 8156

Certificate of Mailing (37 CFR 1.8)

Mail Stop AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22213-1450

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John P. O'Banion
(name)

(signature)
7/14/06

(date)

AMENDMENT

Dear Sir:

In response to the Office Action mailed on 02/14/2006, please amend the above-identified U.S. patent application as follows. A Petition for Extension of Time for two months is being submitted herewith.

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks/Arguments begin on page 20 of this paper.